

AJA Metal Evaporator SOP - SHORT FORM

AJA E-Beam Metal Evaporator SOP

Safety Information and Overview.....	1
Section 1 – Process or Experiment Description.....	2
Section 2 – Hazardous Substances.....	2
Section 3 – Potential Hazards.....	2
Section 4 – Routes of Exposure.....	3
Section 5 – Personal Protective Equipment.....	3
Section 6 – Waste Disposal.....	4
Tool operation.....	4
1. Precheck.....	4
2. Loading Sample and Rack into the Loadlock.....	5
3. Loading Sample into the Main Chamber.....	5
4. Preparing for Film Deposition.....	6
5. Film Deposition.....	6
Ramping up to Threshold.....	6
After Threshold - Ramping up to Soaking.....	7
After Soaking - Ramping up to Desired Rate.....	7
Deposition.....	7
6. Unloading the Sample.....	8
7. Before You Go.....	8
Appendix.....	9
Loading Sample into the Main Chamber.....	9
Preparing for Film Deposition.....	12
Common Errors and Troubleshooting.....	13

Safety Information and Overview

Advanced Science Research Center	Graduate Center CUNY
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SOP Title	AJA E-Beam Metal Evaporator SOP
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Department	NanoFabrication Facility
Room and Building	ASRC G.263

Section 1 – Process or Experiment Description

This SOP is only for the general use of depositing thin films. Only approved users are allowed to use the equipment, after passing a qualification with the tool manager. Any maintenance will be done by trained staff members. Some maintenance creates additional hazards which will be described in the Instrument Manual.

*Note: Any sample preparation is to be done by the user, and this document does not cover any information related to sample preparation. Any materials listed outside of the approved list, must be discussed with the tool manager. NO high vapor pressure materials

Section 2 – Hazardous Substances

Substance Name: Chromium

Common Name: Chrome

Abbreviation: Cr

Substance Name: Silver

Abbreviation: Ag

Section 3 – Potential Hazards

Hazard	Hazard Sign	Hazard Description
Bright e-beam		Serious eye damage may occur if viewed directly at e-beam during use
Electric Shock		Tool operates in extremely high voltages (3-10kV).

Thermal		Sample(s) and sample plate can get hot to touch
Chrome		<p>Exposure to particulate or vapor form may present significant health hazards and is toxic to aquatic organisms.</p> <p>Under the high temperatures involved in e-beam evaporation, metallic Cr can oxidize into Cr(VI), especially in the presence of residual oxygen. This is highly toxic to aquatic organisms and is a known human carcinogen.</p>
Silver		<p>Silver is toxic to aquatic life in nanoparticulate or ionic forms.</p> <p>low acute toxicity, but chronic exposure (especially to nanoparticles or silver dust) may lead to:</p> <p>Argyria: A bluish-gray discoloration of the skin.</p> <p>Respiratory irritation from dust or vapor in poorly ventilated areas.</p>

Section 4 – Routes of Exposure

Eye damage can occur if looking through the viewport window with the shutter open, and not wearing the appropriate protective eyewear.

Electric shock can occur when working with the high voltage feedthroughs or in the back of the electronics rack, without properly grounding the work area beforehand.

Thermal hazard is present if using the e-beam evaporator for a long period of time, which can heat up the plate and the sample(s).

Section 5 – Personal Protective Equipment

All personnel must wear the welding goggles whenever looking directly at the bright e-beam.

All trained staff must use the grounding rod to touch the working areas, before attempting any maintenance.

Section 6 – Waste Disposal

Kapton or copper tape that has silver and/or chrome on the top layer, must be disposed into the container found on the workbench. Staff will transport the container for waste disposal when the container is full.

Hazardous compound, element, or chemical name	State (L,G,S)	Hazardous	Non-hazardous	Which hazards?	How is waste managed?
Silver	S	x		Solid waste is toxic to environment, aquatic, and human health	Must be collected and disposed of as Hazardous waste
Chrome	S	x		Solid waste is toxic to environment and human health	Must be collected and disposed of as Hazardous waste

Tool operation

1. Precheck

1. Check load lock pressure (< 1E-5)
2. Check chamber pressure (~ E-8)
3. Check temp of cryo pumps
 - a. Top/Left cryo (10-11K)
 - b. Bottom/Right cryo (12-13K)
4. Check if other users are on the sputter tool (coordinate load lock usage)
5. Check that the material you need is in the tool
- 6. CONFIRM THAT BOTH GATE VALVES ARE CLOSED**

2. Loading Sample and Rack into the Loadlock

1. Verify BOTH gate valves are closed
2. Vent load lock to atmospheric pressure (~750 Torr)
3. Lift the load lock lid completely
4. Remove rack from the loadlock and load sample on the sample plate
 - a. The sample plate can be inserted on either the 2nd or 3rd level
5. Insert the rack back into the loadlock and pump loadlock to **BELOW** 3E-5 Torr

3. Loading Sample into the Main Chamber

1. Verify the receiving substrate holder (the angle bracket) is in the correct load position (height and rotation)
 - a. Do not go below the bottom sharpie line
 - b. Verify the vertical sharpie line (green line) orients with either the screw groove or red line for correct orientation
 - c. See figures 1+4 in appendix for reference
2. Open viewport shutters
3. Open gate valve when it is **below** 3E-5 Torr
4. Move the load arm to the loadlock.
 - a. First go to the gate valve marking
 - b. Make sure to slowly move towards the loadlock
 - c. The paddle should be below the sample plate
 - d. See figure 2 in appendix for reference
5. Pick up the sample plate
 - a. The sample plate should sit in the middle step of the paddle
 - b. Recall that there is limited clearance between the rack spaces

- c. See figure 2 in appendix for reference
- 6. Retract load arm to the substrate holder position inside main chamber
 - a. The sharpie line closest to the home position of the load arm
- 7. Close gate valve
 - a. The chamber pressure will suffer (you will see a spike in chamber pressure) whenever you open the gate valve. This is normal.
- 8. Use the joystick to lift the sample plate off the loadarm.
 - a. The sample plate must sit on the lowest step of the angle brackets
 - b. You can adjust the loadarm as needed to achieve the above
 - c. See figure 3 in appendix for reference
- 9. Raise substrate holder (with sample plate) to deposition height
 - a. Deposition height is 90mm from the top
 - b. See figure 4 in appendix for reference
- 10. Return load arm to home position
 - a. As long as you are on or above the top sharpie line, the loadarm can be moved back to the home position safely
- 11. Shut the viewport shutters

4. Preparing for Film Deposition

- 1. Turn on HV on the Genius monitor (should say 9.45kV)
- 2. Verify the Genius monitor is in “Automatic Operation”
- 3. Go to the Process Screen
 - a. Select the material desired to deposit
 - b. Must select it twice to actually select that choice
 - c. See figure 5+6 in appendix for reference
- 4. Press “Edit” on the layer screen
 - a. You should only see 1 layer - which is the same as the material selected
- 5. In the “Process Menu: Edit ...: Edit Layer 1.1” screen, you must edit/verify the following:
 - a. Enter a film thickness greater than what you need to deposit
 - b. Verify that the Start Mode is in “Auto” mode
 - c. Sensor 1 must be “On”
 - d. See figure 7 in appendix for reference
- 6. Go back to the main menu and go to the Film menu
 - a. Select the material desired to deposit
- 7. In that material film menu screen, verify the following 2 items
 - a. The pocket number on the screen matches the crucible turret position in reality
 - b. The material name matches to what you will be evaporating
- 8. On the main menu, verify you are operating in “Man/Auto” (as opposed to Auto/Man)
 - a. A white box appears around the “Power” level column when you are in manual mode
- 9. Press the green “Start Button/ Start Layer”
 - a. The EBSH will go from Black to green
 - b. Wait until the crucible turret arrives to your desired material

- c. On the top left of the main screen, it will say “Verify Crystal” for a very brief moment.
- d. It should read “Deposit”, before you start ramping up.

5. Film Deposition

Ramping up to Threshold

1. Ramp up by increasing the power knob slowly and waiting between movements
 - a. Ramping up is:
 - i. **No more than 3% at a time**
 - b. For every movement done, **you must wait anywhere between 30 sec. - 1 min. Before moving the power knob again.**
2. When you start to get a rate on the monitor (ideally $\sim 0.01\text{\AA/s}$), note the power in the log binder
 - a. If it fluctuates to 0 or to negative numbers, that is not a real rate. It's just noise.
3. Check chamber pressure and cryo temperatures periodically
4. Verify the location of the E-beam in the crucible through the viewport window
 - a. If it is too close to the crucible wall or if it is on the crucible, notify staff member to move the beam for you
5. Close the viewport window

After Threshold - Ramping up to Soaking

6. Increase the power slowly until you are midway of the desired deposition rate
 - a. You could try moving 1% first and observe how the rate rises.
 - i. If the rate moves up slowly or within acceptable bounds ($\leq 0.1\text{\AA/s}$), you can increase the power jump slightly.
 - ii. If you see the rate rise more than 0.1\AA/s , then move the power back to the last number you were on. Wait at least 1 minute for the rate to stabilize. Then, try moving again at a slower pace and observe how the rate behaves
7. When you are halfway of the desired rate, soak for a couple of minutes for uniformity
 - a. **Soak for at least 3 minutes**
8. Check chamber pressure and cryo temperatures periodically

After Soaking - Ramping up to Desired Rate

9. At this point, it shouldn't take large power jumps to reach your desired rate.
 - a. Should be increasing the power approximately the same pace
10. Check chamber pressure and cryo temperatures periodically

Deposition

11. When you reached your desired rate, open the substrate shutter to expose your sample

- a. Click on the “S_SH” button
 12. Press the “ZERO” button to zero the starting thickness
 13. Wait until you reached your desired thickness
 - a. You may not leave the cleanroom unless there is an emergency
 - b. You are allowed to work in other areas of the cleanroom, **as long as you periodically check on the chamber pressure, cryo temperatures, the rate, and thickness deposited.**
 14. When you have deposited the film thickness you need, press the “S-SH” button, to shut the shutter.
 15. Slowly ramp down the power until it reaches zero
 - a. Should be about the same pace as when you ramped it up - after soaking
 16. Hit the “Stop/Stop Layer” button
 17. Click “Next Menu”
 18. Hit the “Reset” button
-

**** If depositing another layer(s) of different material repeat steps 4 and 5 ****
(4.Preparing for Film Deposition, and 5. Film Deposition)

6. Unloading the Sample

1. Turn off the HV on the Genius controller.
2. Insert the load arm into the main chamber to receive the sample plate
3. Lower your sample plate onto the load arm
 - a. Make sure the sample plate sits on the middle step feature of the loadarm paddle
4. Lower the substrate holder (angle bracket) to the bottom sharpie line
5. Check that the rack is in the position you need it and that there is no one using the loadlock
6. Verify the pressure in the loadlock is < 3E-5
7. Open the gate valve
8. Transfer your sample to the rack in the loadlock
 - a. When the paddle is in the loadlock, the level/ledge that the sample plate was sitting on the rack originally, should be below the paddle
9. After transferring the sample plate to the rack, retract the arm to its home position
10. Shut the gate valve
11. Vent the load lock and remove your sample.

7. Before You Go...

12. When you leave the tool, verify the following:
 - a. The HV is off on the Genius Controller
 - b. The gate valves are shut (both on the loadlock)

- c. The load lock is evacuated and pumped down.
 - i. You don't need to stay until the loadlock is fully pumped down to vacuum, **but until you see that the pressure numbers are dropping**
 - 13. Enter your deposition info into the log book
 - 14. Enter all films and thicknesses in Badger and log off
-

Appendix

Loading Sample into the Main Chamber

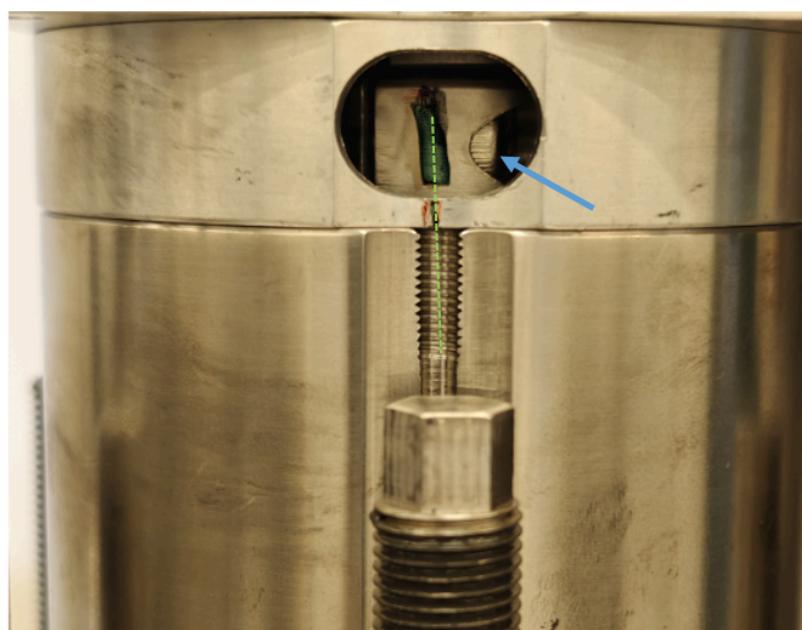


Figure 1

The green dashed line shows that the green sharpie mark is aligned with the screw groove or red sharpie mark (whichever is easiest). *Note: the green sharpie mark will only appear if you can see the screw notched on the side, represented by the blue arrow.*

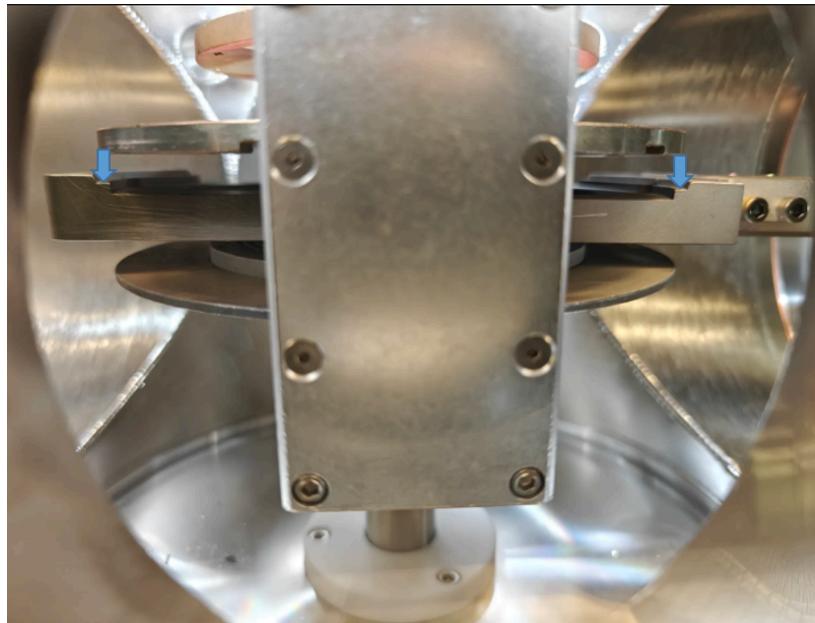


Figure 2

This point of view of looking through the loadlock viewport window. The loadarm paddle is directly below the sample plate. **The goal is to place the sample plate onto the middle step feature on the loadarm, represented by the blue arrows.**

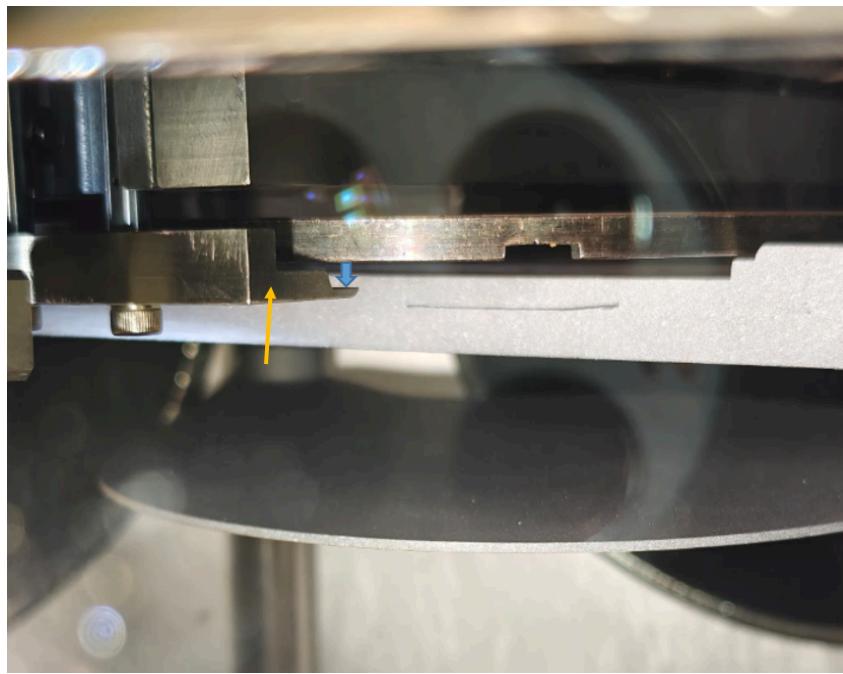


Figure 3

This point of view is looking into the main chamber from the viewport window. The yellow arrow points to the angle bracket. **The blue arrow shows where the sample plate should be placed onto the angle bracket.**

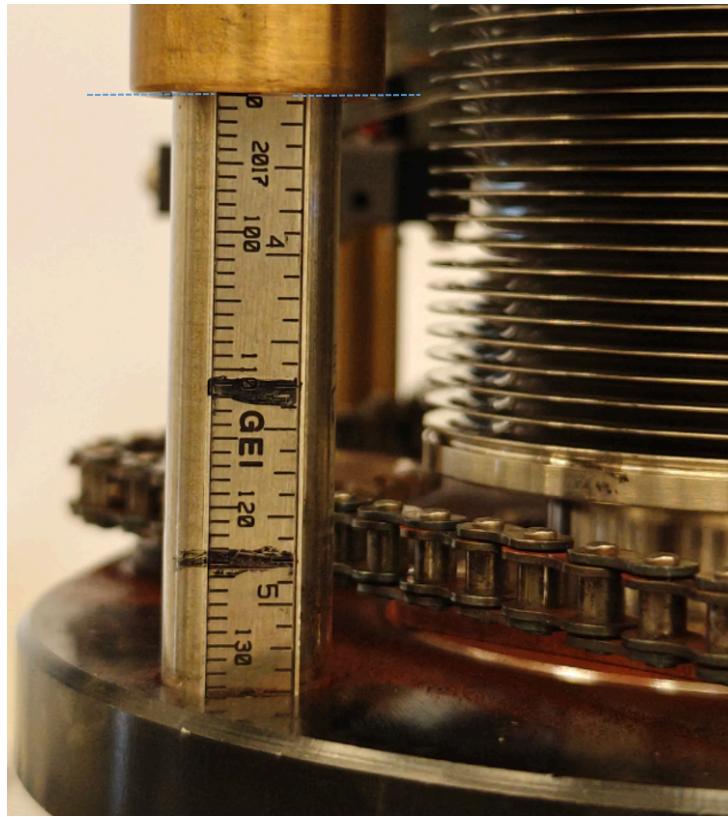


Figure 4

The **bottom** sharpie denotes where the angle brackets should be placed to start the loading process. This is also where you leave the angle bracket when you want to transfer the sample plate back into the loadlock. The **top** sharpie mark is the minimum safe clearance to move the loadarm back to its home position safely. The blue dashed line shows where the angle bracket is at the 90mm mark, the deposition height. *Note: We align the angle bracket to the placemarkers by using the bottom edge of the brass rod.*

Preparing for Film Deposition

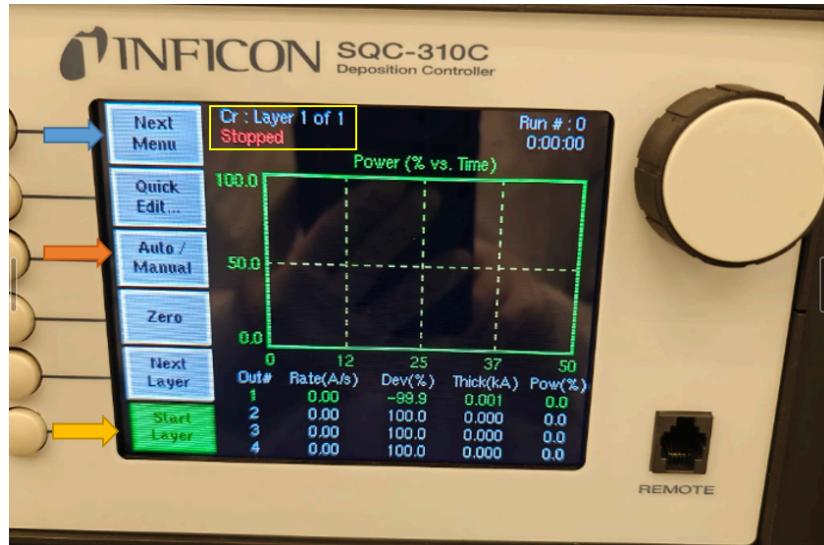


Figure 5

This is the main screen on the Inficon. On the top, in the yellow box, displays the current material recipe loaded, and the state of the process. Next to the blue arrow, is the “next menu” button, that cycles indefinitely through all of the options. Next to the orange arrow, is the “Auto/Manual” button, that you must confirm/adjust to read “Manual/Auto” for using the tool in manual mode. Next to the yellow arrow, is the “Start Layer” button, that you press **once** to start ramping up your deposition process.

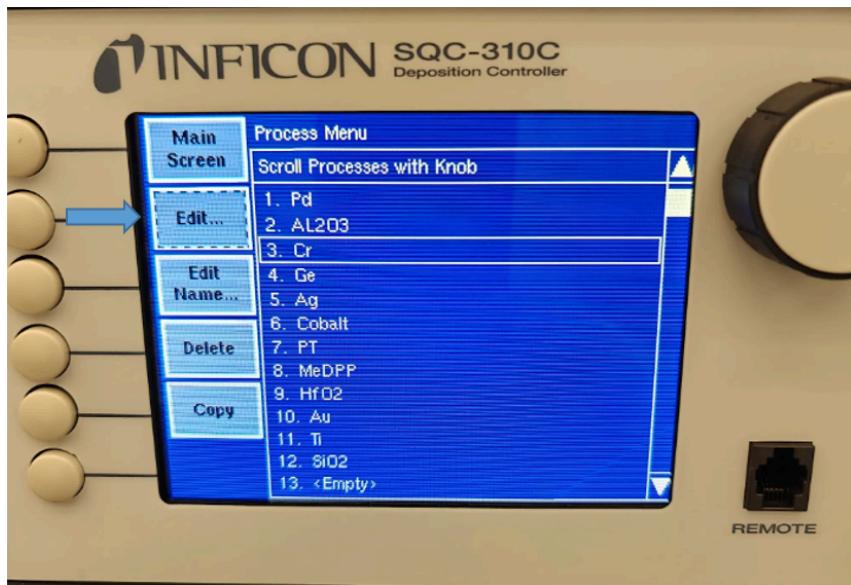


Figure 6

After you press the “Process Menu” button, it takes to this screen to select a material. Choose the material you will be depositing, and **in order to make the selection (or move on to the next screen), you must press it twice**.

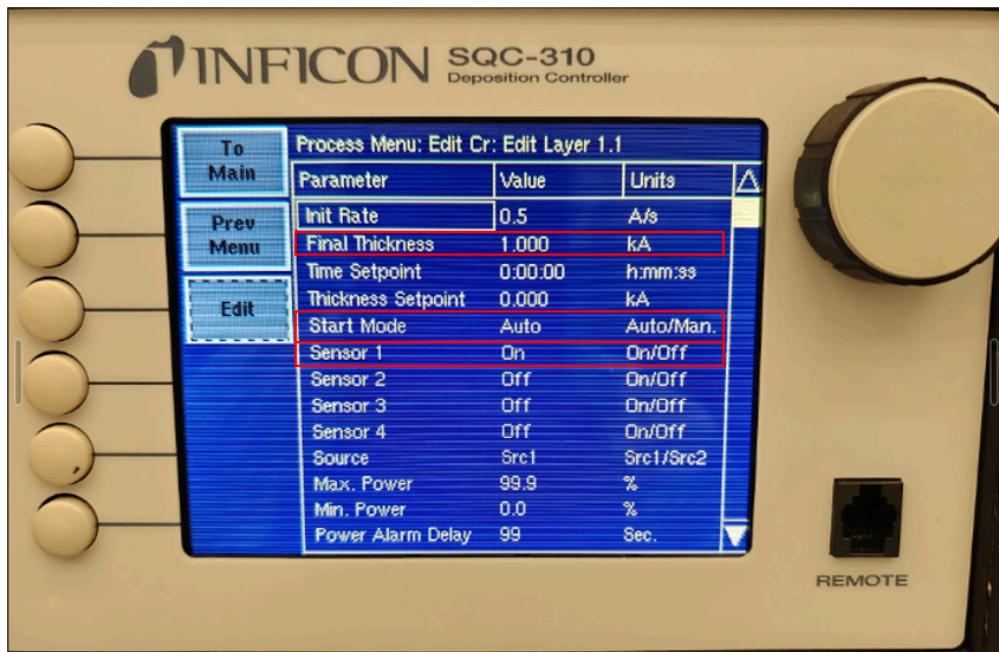


Figure 7

When you are on this screen, you are editing the material's recipe/process. The only parameter to edit here is the "Final Thickness", which you **must set to a number higher than what you want on your sample**. The other 2 parameters: "**Start Mode**" and "**Sensor 1**" must match this photo.

Common Errors and Troubleshooting

- Pocket will not "Rotate"
 - Crucible index may be in "Local" Mode – needs to be in "remote" for crucibles to automatically be accessed.
- Crucible turret arm does not align to the pocket indicator
 - Press "Home" in the crucible menu on the Inficon
 - The step motor occasionally skips steps. This is remedied by readjusting the yellow "home lights" at 1st and 6th position.
- Genius Controller - "Low Voltage" Error
 - Check that the Crystal sensor is on – and also that the ion gauge is turned on. The tool is interlocked to not turn on if either of these sensors are not on and connected.
- Genius Controller - "High Voltage Minimum" Error
 - Arcing at the electrodes
 - Usually occur in the organic evaporator - can hear popping noises
 - Check that cup insulator is still white
 - If it's black or discolored, looks burned or damaged
 - Needs to be removed for cleaning by scott brite and IPA

- If really damaged, replace completely

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Reviewed/Revised:

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